



*IFW*

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Attorney Docket No. 100116)

IN THE APPLICATION OF: )  
David Mikolas et al. )  
 ) Examiner:  
Serial 10/752,416 ) George Binh Minh Nguyen  
No. )  
 ) Group Art Unit: 3723  
Filed: January 6, 2004 )  
 ) Confirmation No.: 3899  
Title: Micromachining by Chemical )  
Mechanical Polishing )

RESPONSE TO THE OFFICE ACTION  
MAILED DECEMBER 3, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office action of December 3, 2004,  
please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this  
paper.

**Amendments to the Claims** are reflected in the listing of  
claims which begins on page 4 of this paper.

**Amendments to the Drawings** begin on page 7 of this paper  
and include an attached replacement sheet.

**Remarks/Arguments** begin on page 8 of this paper.

An **Appendix** including amended drawing figures is attached  
following page 15 of this paper.